



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Agarwal et al.**Application No.** 10/002,779**Filed:** October 29, 2001**Confirmation No.** 6254

For: METHODS FOR FORMING AND
INTEGRATED CIRCUIT STRUCTURES
CONTAINING RUTHENIUM AND
TUNGSTEN CONTAINING LAYERS

Examiner: David Vu**Art Unit:** 2818**Attorney Reference No.** 6047-61466

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney
for Applicant(s)

Date Mailed April 20, 2004

TRANSMITTAL LETTER

Enclosed is an Amendment for the above application. The fee has been calculated as shown below.

CLAIMS AS AMENDED					
For	No. after amendment	No. paid for previously	Present Extra	Rate	Fee
Total Claims	14	- 20*	= 0	\$18.00	\$ 0.00
Indep. Claims	5	7**	= 0	\$86.00	\$ 0.00
Mult. Dep. Claims Fee (if not previously paid)					\$290.00
One-month Extension of Time					\$110.00
Two-month Extension of Time					\$420.00
Three-month Extension of Time					\$950.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$420.00

* greater of twenty or number for which fee has been paid.

** greater of three or number for which fee has been paid.

If an additional extension of time is required please consider this a petition therefor.

- Please charge any fees that may be required in connection with filing this amendment and any extension of time to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

By



Michael D. Jones
Registration No. 41,879

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Attorney
for Applicant(s) *[Signature]*

Date Mailed April 20, 2004

AMENDMENT

This responds to the Office action dated November 28, 2003. Please amend the referenced application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2.

Remarks begin on page 6.

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